

<b>Notice of References Cited</b>	Application/Control No. 10/652,253		Applicant(s)/Patent Under Reexamination HAFREN, JONAS	
	Examiner Dai A. Phuong		Art Unit 2617	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0108156	05-2005	Sumino et al.	705/040
*	B	US-2003/0093545	05-2003	Liu et al.	709/231
*	C	US-2003/0216145	11-2003	Cox et al.	455/456.1
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	K	US-			
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